



1762.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Chung J. Lee, et al.

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For: **DIELECTRIC THIN FILMS FROM FLUORINATED PRECURSORS.**

Commissioner of Patents  
Washington, D. C. 20231

Sir:


FIRST CLASS MAIL

DATE OF DEPOSIT: April 29, 2003

**TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT WITHIN THREE MONTHS OF FILING OR BEFORE MAILING OF FIRST OFFICE ACTION**

The information disclosure statement submitted herewith is being filed within three months of the filing date of the application or date of entry into the national stage of an international application or before the mailing date of a first Office Action on the merits, which ever event occurs last 37 C.F.R. § 1.97(b).

Respectfully submitted,  
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